

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hojo et al.
Appl. No. : 10/553,083
Filed : October 11, 2005
For : POSITIVE RESIST
COMPOSITION AND METHOD
OF FORMATION OF RESIST
PATTERN
Examiner : C. Hamilton
Group Art Unit : 1752

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed **July 3, 2007**, Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks.

The listing of claims begins on page 2 of this paper. The claims are provided for the Examiner's convenience. No amendments have been made.

Remarks begin on page 5 of this paper.